



Bunch shape with electro optic techniquemeasurements on the limits

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Outline

FLUTE



- What is FLUTE machine and motivation
- What to use for bunch length measurement?
- Principles of electro-optical bunch length measurements
- Simulations of a bunch length monitor
- Measurements at SwissFEL ITF
- Summary & outlook

Location



KIT Campus North, Karlsruhe, Germany





- <u>Ferninfrarot Linac- Und Test Experiment</u>
- FLUTE accelerator test facility at KIT





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 - Bunch compression studies for different compression schemes
 - Wide range of bunch charges and lengths
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High dynamic range/adaptive

Non-destructive





<u>Ferninfrarot Linac- Und Test Experiment</u> FLUTE – accelerator test facility at KIT Bunch compression studies for different Bunch length monitor compression schemes High dynamic range/adaptive Wide range of bunch charges and lengths Different coherent THz radiation Non-destructive generation schemes EO-based bunch length monitor Bunch Photoinjector e-gun Linac THz compressor Quadrupoles generation



FLUTE key parameters

Final electron energy	42	MeV
Electron bunch charge	1 - 3000	рС
Electron bunch length	1- 300	fs
Pulse repetition rate	10	Hz
Length	~15	m



Locations of interest for longitudinal diagnostics





Principles of Electro-Optical Spectral Decoding







Laser System



Yb-doped fiber laser 1030 nm*





EO system installed at ANKA



* Courtesy of Peter Peier, Desy





Single-shot method





Simulation



Tool: MATLAB based code – developed by B. Steffen (DESY)

Main Input parameters:

	Electron Bunch	Lase	Crystal & Detection
		σ_{λ} - spectral width	Material (GaP)
Fixed	γ – energy (7, 42 MeV)	λ – wavelength (1030 nm – Yb-doped)	Wave-plate settings
Varied	Q – charge		Distance to e-beam
	σ_z – length	σ_{T} – pulse length	Thickness of a crystal
	Aim: Determine	optimal settings for bunc	h-length monitor

Locations of interest for longitudinal diagnostics



Simulation Results





Simulation Results





Simulation Results







EOSD signal – after Gun (7 MeV)





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Electro-Optical bunch length measurements

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EOSD signal – after Gun (7 MeV)













EOSD signal – after Gun (7 MeV)



EOSD signal – after linac (42 MeV)





EOSD signal – after chicane (42 MeV)





Simulation Summary

Position 1: After Gun Challenge – Iow γ Limits – Low charge density

Position 2: After linac Measurement conditions reliable

Position 3: After chicane Crystal thickness become more important Laser pulse length plays stronger role Too strong signal



Conclusion:

- Thick crystal
- Bring it close
- Even 1 pC measurable
- Thinner crystal

Measurements at Swiss FEL TIF





* Courtesy of Yevgeniy Ivanisenko, PSI

Measurements at low energies





Recent development



Laser assembly at DESY



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Thank you for your attention!

